



03560.003365.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
MICHIO HORIKOSHI ET AL.)
Application No.: 10/681,311)
Filed: October 9, 2003)
For: FABRICATION METHOD FOR)
ELECTRON SOURCE)
SUBSTRATE)
Examiner: A.C. Stevenson
Group Art Unit: 2812
)

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER ALLOWANCE

Sir:

The issue fee being paid herewith, please amend the above-identified application as follows pursuant to 37 C.F.R. § 1.312.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on August 4, 2004.

(Date of Deposit)

FRANK A. DeLUCIA (REG. NO. 42,476)

(Name of Attorney for Applicant)

August 4, 2004

August 4, 2004